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SEINELENGIA 78 (THERMODOUFLE(4A) DUARTZ)(6A)(ALUMINUM(W)OXIDE (THERMOLOUFLE(8A) SUAR(2)(F)(ALUMINUM(W)DX1DE) #1(6)# UN (THERMUCOUPLE (SA) QUARTZ) (F) (ALUMINA) QUARIZ(SA) TUBE AND (ALUMINUM(W) OXIDE OK ALUM) 21/ S (QUARTZ(SA) (UBE)(P)(ALUMINUM(W)OXIDE OR ALUMI 34 S (QUARIZ(SA) (USE) AND (ALUMINUM(W)OXIDE OR ALU 3 S L6 AND THERMUCOUPLE

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- 3. 4,284,7/1, Aug. 18, 1981, Process for preparing melamine; Hsuan L. Hen, et al., 544\*200
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- 2. 4,244,935, Jan. 13, 1981, Method of forming metal chlorides; M. Benjamin Dell, 423\*491, 137, 492, 493, 494, 496; 42/\*221
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## (FILE USPAT)

		SET	FAGE	LENGTH 19		
				LENGTH 78		
L1	102	SC	XYGEN	(W) SENSOR	AND	THERMOCOUPLE
L2	. 16	S L	1 AND	MOLTEN		THE RESERVE CE
L3	Ø	SL	1 AND	U-TUBE		
L4	Ø	SL	1 AND	U(W) TUBE		
L5	988	S L	I (W) TUI	BE		
L6	64	S L	5 AND	THERMOCOL	JPLE	
L.7				OXYGEN (W)		SOR
LB				73/CLAS C		
L9	16	SL	1 AND	(73/CLAS	OR 3	74/CLAS)

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- 2. 4,708,783, Nov. 24, 1987, Apparatus for the determination of silicon in molten metal: Hajime Nakamura, et al.,  $204 \pm 423$
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- 4. 4,657,641, Apr. 14, 1987, Determination of silicon in molten metal; Hajime Nakamura, et al., 204\*1T, 422
- 5. 4,644,138, Feb. 17, 1987, Temperature control system with simplified controller and power supply: Paul L. Walsh, 219\*501: 204\*1T; 219\*497; 323\*245; 330\*75, 103
- 6. [4,627,892], Dec. 9, 1986, Electrochemical sensors and methods for their manufacture and use; Wayne L. Worrell, et al., 204\*1T, 422; 264\*570; 501\*103, 152
- 7. 4,451,350. May 29. 1984, Sensor for measuring density of oxygen in molten metal; Yutaka Tsuchida, et al., 204\*422, 423
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